

**Electronic Patent Application Fee Transmittal**

<b>Application Number:</b>	10723714			
<b>Filing Date:</b>	26-Nov-2003			
<b>Title of Invention:</b>	Method for etching high dielectric constant materials and for cleaning deposition chambers for high dielectric constant materials			
First Named Inventor/Applicant Name:	Bing Ji			
<b>Filer:</b>	Rosaleen P. Morris-Oskanian			
<b>Attorney Docket Number:</b>	06299P2 USA			
Filed as Large Entity				
<b>Utility Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				
Extension - 2 months with \$0 paid	1252	1	450	450

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>450</b>